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REASONS FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance: the claimed method and apparatus including steps of adsorption process gas purification to remove gaseous transition metal impurities with a furnace to expose, contain, or dry or dope a soot perform is not found in the prior art either singly or in combination. These features are found recited in the alternative in each of independent claims 1, 18, and 29. The closest prior art reference is considered DeLuca (US 3,933,454), cited in this action, which discloses forming a soot perform with flame hydrolysis to form and optical fiber waveguide, but does not address metal impurities. The most relevant non-patent literature reference is considered reference AS cited by the applicants and the most relevant foreign reference is considered reference AM, also cited by the applicants in the June 30, 2003 information disclosure statement. Other prior art references cited in this application contain one or more elements of the claimed invention, but are not considered to disclose the necessary motivation or combination suggestion to obviate the claimed invention.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Stephen Gravini whose telephone number is 571 272

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4875. The examiner can normally be reached on normal weekday business hours (east coast time).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Ira S. Lazarus can be reached on 571 272 4877. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Steple Garini

SMG

April 25, 2005